Appl. No. 10/605,585

Response dated July 14, 2006

Reply to Office Action mailed May 3, 2006

AMENDMENTS TO THE CLAIMS:

Please amend the claims as follows:

Claim 1 (currently amended): A semiconductor device, comprising:

a unitary and non-layered semiconductor substrate comprising a thin portion that is

thinner than adjacent portions of the semiconductor substrate, and a recessed portion formed

below the thin portion;

wherein the etching rate of the thin portion is slower than that of the surrounding

portions of the semiconductor substrate; and

at least one through hole is formed in the thin portion that extends from the recessed

portion, and entirely through the thin portion to the upper surface of the semiconductor

substrate; and

a dopant is infused in at least a portion of the thin portion that is immediately adjacent

to the at least one through hole.

Claim 2 (cancelled)

Claim 3 (cancelled)

Claim 4 (original): The semiconductor device set forth in claim 1, wherein the thin

portion is formed by means of a selective oxide film.

Claims 5-12 (cancelled)

Claim 13 (new): The semiconductor device set forth in claim 1, wherein the dopant is

infused in the entire thin portion.

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